

Docket No. 8663-0001-2X

IN RE APPLICATION OF: HIDEKAZU KIKUCHI

SERIAL NO: 09 557,156

FILED: APRIL 25, 2000

FOR: TRANSFER METHOD AND APPARATUS...

RESPONSE TO OFFICE ACTION 116-
EXPEDITE TO USE EXAMINING
GROUP 038/116

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☒ Additional documents filed herewith: Marked-Up Copy of Amendment

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	40	MINUS	41	0	× \$18 =	\$0.00
INDEPENDENT	5	MINUS	5	0	× \$84 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS				+ \$280 = \$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment				+ \$40 = \$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of _____ is attached.
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO.: 8663-0001-2X

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIDEKAZU KIKUCHI : EXAMINER: BERMAN, J. I.
SERIAL NO: 09/557,156 :
FILED: APRIL 25, 2000 : GROUP ART UNIT: 2881
FOR: TRANSFER METHOD AND :
APPARATUS, EXPOSURE
METHOD AND APPARATUS,
METHOD OF MANUFACTURING
EXPOSURE APPARATUS, AND
DEVICE MANUFACTURING
METHOD

AMENDMENT UNDER 37 C.F.R. §1.116

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action of December 23, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

Please cancel Claim 12 without prejudice.

Please amend Claims 1, 15, 25, 29, 36, and 39 to read as follows:¹

1. (Twice Amended) A transfer method of transporting an object having a pattern to be transferred to/from a stage provided in an exposure apparatus in which a substrate is exposed to an exposure beam from the object for manufacturing a microdevice, the method comprising:

¹ A marked-up copy of the amendments is attached hereto.